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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/711,556	09/24/2004	Patrick J. McGinnis	FIS920040161	5555
32074	7590 02/24/2005		EXAMINER	
INTERNAT	TIONAL BUSINESS MA	NGUYEN, JIMMY		
DEPT. 18G BLDG. 300-	482		ART UNIT	PAPER NUMBER
2070 ROUTE 52 HOPEWELL JUNCTION, NY 12533			2829	
			DATE MAILED: 02/24/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)				
Office Action Summan	10/711,556	MCGINNIS ET AL.				
Office Action Summary	Examiner	Art Unit				
	Jimmy Nguyen	2829				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply if NO period for reply is specified above, the maximum statutory period w.  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be tim within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from to cause the application to become ABANDONEI	ely filed will be considered timely. the mailing date of this communication. (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 24 Se	eptember 2004.					
2a) ☐ This action is <b>FINAL</b> . 2b) ☒ This	This action is FINAL. 2b)⊠ This action is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.				
Disposition of Claims						
4) ☐ Claim(s) 1 - 20 is/are pending in the application 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-20 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	vn from consideration.					
Application Papers						
9) The specification is objected to by the Examiner 10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the or Replacement drawing sheet(s) including the correction of the original transfer of the original transfer of the original transfer of the correction of the original transfer or the original	epted or b) objected to by the Edrawing(s) be held in abeyance. See on is required if the drawing(s) is obj	ected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Application ity documents have been receive n (PCT Rule 17.2(a)).	on No ed in this National Stage				
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 0904.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:					

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#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States

2. Claims 1 – 3, 6 – 13, 16 – 19 are rejected under 35 U.S.C. 102(b) as being anticipated by Lo (US 6,462,814).

As to claims 1, 11, Lo disclosed (figs 1 - 3) a system and a method for critical parameter analysis (CPA) of a semiconductor device (DUT, 12), comprising:

a focused optical beam scanning device (16, fig 3) for scanning and imaging the semiconductor device (DUT, 12) and for imparting light energy to illuminated portions of the semiconductor device (DUT, 12) during scanning,

automated test apparatus (ATE, 62, fig 1) for providing predefined stimulus to the semiconductor device (DUT, 12) and for comparing responses from the semiconductor device (DUT, 12) against a set of predefined expected responses,

and

a signal generator (test vectors, column 4 lines 46- 47) for providing an output signal indication when the automated test apparatus (ATE, 62) detects a difference between the responses from the semiconductor device (DUT) and the predefined expected responses, wherein said focused optical beam scanning device and said ATE are adapted such that both operate upon the semiconductor device simultaneously.

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As to claims 2, 12, Lo disclosed (figs 1 - 3) a system wherein semiconductor device (DUT, 12) is fixtured such that ATE (62) connections to the device (12) are made within a scanning chamber of the focused optical beam scanning device (16).

As to claims 3, 13, Lo disclosed (figs 1 - 3) a system wherein focused optical beam scanning device (16) is a laser scanning microscope (LSM).

As to claims 6 - 8, 16 - 18, Lo disclosed (figs 1 - 3) a system wherein predefined stimulus is provided to automated test apparatus (ATE, 62) in the form of a set of test vectors (column 4 lines 45 – 47).

As to claim 9, Lo disclosed (figs 1 - 3) a system wherein output signal indication is a short pulse generated when a difference is detected between responses by semicondutor device (DUT) to predefined stimulus and the predefined expected responses.

As to claims 10, 19, Lo disclosed (figs 1 - 3) a system wherein ate (62) is configured to repeatedly cycle said predefined stimulus from a starting point up a point of failure when such failure is detected

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### Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 4, 5, 14, 15, 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over by Lo (US 6,462,814) in view of Lo et al (US 6,566,897).

As to claims 4, 5, 14, 15, 20, Lo disclosed (figs 1 - 3) a system for critical parameter analysis (CPA) of a semiconductor device (DUT, 12), comprising:

a focused optical beam scanning device (16, fig 3) for scanning and imaging the semiconductor device (DUT, 12) and for imparting light energy to illuminated portions of the semiconductor device (DUT, 12) during scanning,

automated test apparatus (ATE, 62, fig 1) for providing predefined stimulus to the semiconductor device (DUT, 12) and for comparing responses from the semiconductor device (DUT, 12) against a set of predefined expected responses,

and

a signal generator (test vectors, column 4 lines 46- 47) for providing an output signal indication when the automated test apparatus (ATE, 62) detects a difference between the responses from the semiconductor device (DUT) and the predefined expected responses, wherein said focused optical beam scanning device and said ATE are adapted such that both operate upon the semiconductor device simultaneously.

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However, Lo is silent on the image converting means.

On the other hand, Lo et al teach image converting means for representing output from said focused optical beam scanning device (12) as a viewable video signal (84, 62) and for overlaying the output signal indication from the ATE on said viewable video signal', and display (62) means for viewing said video signal with overlaid ATE output signal indication.

It would have been obvious to one having an ordinary skill in the art at the time of the invention was made to add the viewable video signal for the purpose to observing the defected image.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jimmy Nguyen whose telephone number is (703) 306-5858. The examiner can normally be reached on M-F from 9 to 5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ramiz Nestor, can be reached on 571-272-2034. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

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you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

Jimmy Nguyen

2/16/2005

VINH NGUYEN PRIMARY EXAMINER

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